



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2229

Applicants: Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Method For Growing Oxide Film
Serial No.: 10/085,498 Filing Date: February 20, 2002
Examiner: Unassigned Group Art Unit: Unassigned
Docket No.: M-11549US

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INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Dear Sir:

Pursuant to 37 C.F.R. §1.97, Applicant wishes to call the following documents (copies enclosed) to the attention of the Examiner.

1. A PTO form 1449 listing these documents is enclosed.

Citation of the above documents shall not be construed as:

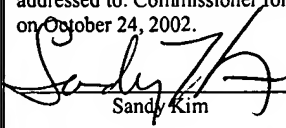
1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, or
3. an admission that the information cited herein is, or is considered to be material to patentability as defined in §1.56(b).

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Applicant(s) believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 50-2257. Please deduct any additional fees from, or credit any overpayment to the above-noted Deposit Account.

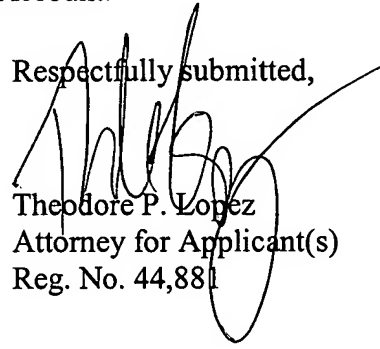
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on October 24, 2002.



Sandy Kim

October 24, 2002
Date of Signature

Respectfully submitted,



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